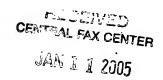
CENTRAL FAX CENTER

RCE TRANSMITTAL LETTER(Large Entity)  Docket No.											
Applicant(s): Yoshi Ono							SLA0669				
Serial No F		Filing	g Date	Exar	Examiner		Group Art Unit				
10/602,194		June 23, 2003		Khiem D	Khiem D. Nguyen		2823				
Invention: Low Temperature Nitridation of Silicon											
	TO THE COMMISSIONER FOR PATENTS:										
This is a Request for Continued Examination (RCE) under 37 C.F.R. 1.114 of the above-identified application.											
The fee has been calculated and is transmitted as shown below.											
CLAIMS AS AMENDED  CLAIMS REMAINING HIGHEST # NUMBER OF EXTRA DATE ADDITIONAL											
	AFTER A	REMAINING MENDMENT	HIGHEST # PREV. PAID F	OR CLAIMS	PRESENT	RATE	ADDITIONAL FEE				
TOTAL CLAIMS	. 20		. 20 = .			\$50.00	\$0.00				
INDEP. CLAIMS		3 -	3 =		0 x	\$200.00	\$0.00				
Multiple Deper	\$0.00										
	\$0.00										
The submission required under 37 C.F.R. 1.114 was previously submitted on 11/15/2004.  Please charge Deposit Account No. 19-1457 in the amount of \$790.00, which consists of the fee of \$790.00 specified in 37 CFR 1.17(e), plus any fee required by 37 CFR 1.111, as calculated above.  A duplicate copy of this sheet is enclosed.  A check in the amount of to cover the filling fee is enclosed.  The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1457.  A duplicate copy of this sheet is enclosed.  X Any additional fees required under 37 C.F.R. 1.16.  X Any patent application processing fees under 37 C.F.R. 1.17.											
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W W CD	Matthew I	). Rabdau, Reg.	No. 43,026	Dated:	January 1	. 1, 2000					
I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office under 37 C.F.R. §1.8 at Fax No. (703) 872-9306 on January 11, 2005.  Matthew D. Rabdau, Reg. No. 43,026  Note: Each paper must have its own certificate or transmission, or this certificate must identify each submitted paper. The papers submitted											
include:	~	1 73			T)1/		· · · · · · · · · · · · · · · · · · ·				
X This Re	2	page(s)									
<ul> <li>X Remarks in connection with filing of RCE under 37 CFR § 1.114</li> <li>Attachments</li> <li>page(s)</li> <li>pages</li> </ul>											
Petition for Extension of Time under 37 C.F.R. § 1.136 (Include Duplicate )											
Total pages, including this Transmittal: 4											

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Applicant(s):		SLA0669										
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Serial No Filing			Date Examiner		Gi	Group Art Unit						
10/602,194 Ju		June 2	3, 2003	Khiem D. Nguyen		2823						
Invention: Lov	v Temperat	ure Nitridation	of Silicon									
TO THE COMMISSIONER FOR PATENTS:												
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The fee has been calculated and is transmitted as shown below.												
			CLAIMS AS A			ADDITIONAL						
		REMAINING MENDMENT	HIGHEST # PREV. PAID FOR	NUMBER OF EXTR		FEE						
TOTAL CLAIMS	20	) -	20 =	0	x \$50.00	\$0.00						
INDEP. CLAIMS		3 -	3 =	. 0	x \$200.00	\$0.00						
Multiple Dependent Claims (check if applicable) \$0.00												
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT												
The submission required under 37 C.F.R. 1.114 was previously submitted on 11/15/2004.  X Please charge Deposit Account No. 19-1457 in the amount of \$790.00, which consists of the fee of \$790.00 specified in 37 CFR 1.17(e), plus any fee required by 37 CFR 1.111, as calculated above.  A duplicate copy of this sheet is enclosed.  A check in the amount of to cover the filling fee is enclosed.  X The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1457.  A duplicate copy of this sheet is enclosed.  X Any additional fees required under 37 C.F.R. 1.16.  X Any patent application processing fees under 37 C.F.R. 1.17.  Dated: January 11, 2005  Matthew D. Rabdau, Reg. No. 43,026  I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office under 37 C.F.R. §1.8 at Fax No. (703) 872-9306 on January 11, 2005.  Matthew D. Rabdau, Reg. No. 43,026  Note: Each paper must have its own certificate or transmission, or this certificate must identify each submitted paper. The papers submitted include:  X This Request for Continued Examination Transmittal (Include Duplicate) 2 page(a)												
x Remarks in connection with filing of RCE under 37 CFR § 1.114 2 page(s)  Attachments 0 page(s)												
Attach	ments	· · · · · · · · · · · · · · · · · · ·			· · · · · · · · · · · · · · · · · · ·	bage(s)						
Petition for Extension of Time under 37 C.F.R. § 1.136 (Include Duplicate )  Total pages, including this Transmittal: 4												

Appl. No. 10/602,194 Response dated January 11, 2005 Reply to Office Action of August 16, 2004



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Inventors: Yoshi Ono

Serial No: 10/602,194

Filed:

June 23, 2003

Title:

LOW TEMPERATURE

NITRIDATION OF SILICON

PATENT APPLICATION

Attorney Docket No. SLA0669

Group No. 2823

Examiner:

Khiem D. Nguyen

January 11, 2005

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. § 1.114

Sir:

This communication responds to an Advisory Action dated

December 10, 2004 in the above identified patent application. The submission
required under 37 C.F.R. 1.114 was previously submitted on 11/15/2004, in
response to an office action dated August 16, 2004. The submission on 11/15/2004
was a Request for Continued Examination, which was mischaracterized as an
Amendment after Final.

## REMARKS

The submission on 11/15/2004 included a coversheet entitled RCE Transmittal, which authorized a \$790.00 fee as required for an RCE, along with a Preliminary Amendment in Support of RCE Under 37 C.F.R. § 1.114, which was

SLA0669 Request for Continued Examination

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Appl. No. 10/602,194 Response dated January 11, 2005 Reply to Office Action of August 16, 2004

addressed to MS RCE. It is unclear to Applicant how this submission could be characterized as an amendment after final.

When speaking on the phone with the Examiner on January 11, 2004, the Examiner indicated that an RCE form was not indicated in the file, although he acknowledged that the transmittal was entitled RCE transmittal and that the footer of every page of the amendment indicated that it was in support of an RCE. Examiner Nguyen indicated that an RCE form should be submitted so that it could be entered.

37 C.F.R. § 1.114 provides the requirements for a Request for continued examination. There is no requirement for a specific RCE form. The Applicant submitted an RCE transmittal along with a Preliminary Amendment in Support of RCE Under 37 C.F.R. § 1.114, which satisfies 37 C.F.R. § 1.111. This submission was timely and provided for the necessary fee. This resubmission should not be necessary and it would be inappropriate to require Applicants to pay any extension fees at this time. However, Applicants have authorized any patent application processing fees under 37 C.F.R. 1.17 that may be required, including extension fees, just in case.

Respectfully submitted,

Date: far my 11, 2005

Matthew D. Rabdau, Reg. No. 43,026

Matthew D. Rabdau, Patent Attorney Sharp Laboratories of America, Inc. 5750 NW Pacific Rim Blvd. Camas, WA 98607

Telephone: (360) 834-8567 Facsimile: (360) 817-8505

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